

Special Issue

Nanostructured Optoelectronic and Nanophotonic Devices

Message from the Guest Editors

The advancement of nanostructured materials development and the understanding of inclusive photo-physical phenomena have significantly contributed to the advancement of the optoelectronic field.

Furthermore, integrating nanomaterials with photonics has paved the way for developing highly efficient nanophotonic devices, which leads to improved interactions between light and matter. This Special Issue, “Nanostructured Optoelectronic and Nanophotonic Devices”, invites the authors to submit the recent results as original communications, articles, and reviews.

Guest Editors

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